

Patent Assignment Abstract of Title

Total Assignments: 1

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Inventor: NOBUMASA SUZUKI

Title: MICROWAVE PLASMA PROCESSING APPARATUS AND METHOD THEREFOR

Assignment: 1

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Assignor: SUZUKI, NOBUMASA

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Assignee: CANON KABUSHIKI KAISHA

30-2, 3-CHOME, SHIMOMARUKO, OHTA-KU
TOKYO, JAPAN

Correspondent: FITZPATRICK, CELLA, HARPER & SCINTO

LAURA A. BAUER
277 PARK AVENUE
NEW YORK, NY 10172-0194

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